

DOCKET NO: 285995US26PCT

IN THE UNITED STATES PATENT & TRADEMARK OFFICE

IN RE APPLICATION OF :
KOHEI KAWAMURA, ET AL. : EXAMINER: PARENDO, KEVIN A.
SERIAL NO: 10/567,733 :
FILED: FEBRUARY 10, 2006 : GROUP ART UNIT: 2823
FOR: METHOD FOR FORMING FILM, :
METHOD FOR MANUFACTURING
SEMICONDUCTOR DEVICE,
SEMICONDUCTOR DEVICE AND
SUBSTRATE TREATMENT SYSTEM

AMENDMENT UNDER 37 C.F.R. § 1.111

COMMISSIONER FOR PATENTS
ALEXANDRIA, VIRGINIA 22313

SIR:

In response to the Office Action dated April 8, 2009, please amend the above-identified application as follows:

Amendments to the Specification begin on page 2 of this paper.

Amendments to the Claims are reflected in the listing of claims which begins on page 4 of this paper.

Amendments to the Drawings begin on page 10 of this paper and include an attached replacement sheet.

Remarks/Arguments begin on page 11 of this paper.